

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Izumi FUSEGAWA et al.

Group Art Unit: 1722

Application No.: 10/510,695

Examiner: G. RAO

Filed: October 8, 2004

Docket No.: 121356

For: METHOD OF MANUFACTURING SILICON SINGLE CRYSTAL, SILICON SINGLE CRYSTAL AND SILICON WAFER

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the June 15, 2006 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims;

Remarks.